



Tool Make & Model

Tool Configuration / Specifications

<i>Item</i>	<i>Part Number</i>	<i>Qty</i>	<i>Description</i>
1	UETCH-SYS	1	Single wafer Primaxx uEtch System for HF Vapor MEMS etch release. Includes Primaxx uEtch Module and System Base Cabinet. Installation is NOT included.
			Quote Total

Optional Items:

<i>Item</i>	<i>Part Number</i>	<i>Qty</i>	<i>Description</i>
1	U-INSTALL	1	System installation support by SPTS and/or local representative (2 days on site) – includes functionality overview and maintenance procedures
2	U-TRAINING	1	Comprehensive on-site post-installation HF Vapor Technology Process Training by SPTS and/or local representative (2 days on site)
3	U-INST/TRG	1	Combined installation/comprehensive training by SPTS and/or local representative (4 days on site)
4	KIT023454	1	Alcohol Vapor/HF Vapor Gas Detection Module
5	PMP023206	1	Ebara EV-S20P 200 – 220VAC 3-phase Dry Pump per Process Module
6	3003759	1	Ebara EV-S20P 380 – 440VAC 3-phase Dry Pump per Process Module
7	KIT023115	1	Seismic Anchor set for System Base Cabinet
8	KIT023841	1	Gas Detection Interface Kit (customer detectors)
9	REA022797	1	Standard sample processing tray
10	SPECIAL	1	Sample processing tray with custom design
11	KIT023447	1	12 Month PM kit, with HF/Alcohol sense elements
12	2052980	1	12 Month PM kit, no HF/Alcohol sense elements
13	KIT023871	1	Level 1 Spares Kit for uEtch Module

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The information contained in this data sheet is, to our knowledge, accurate. We do not warrant the completeness or accuracy of the information contained herein. Any offer by you to purchase the equipment described in this data sheet shall be subject to the terms and conditions of sale.

